

# Endpoint Detection

## Optical Emission Spectroscopy Solutions for Plasma Diagnosis



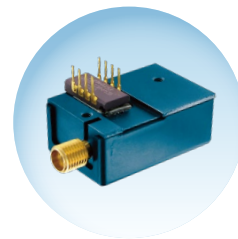
**iHR320/550**



**M116**



**EV 2.0 Series**



**VS-20**

R&D

Mass Production



**VU90**



**OES-Star**



**VS-70**

Plasma Distribution Analysis

Multi-fiber coupled spectrometer allows simultaneous detection of plasma emission from different point



**M116**

Make the invisible Plasma Reactions visible

High throughput spectrometer from Deep UV to visible range



**VU90**

Robust Endpoint detection for low open area

Combination of high throughput and high resolution optical emission spectrometer with advanced endpoint algorithm



**EV 2.0 Series**

**OES-Star**